



PATENT
ATTORNEY DOCKET: 46884-5388

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Fumitsugu FUKUYO et al.)	Confirmation No.: 4531
)	
Application No.: 10/537,509)	Group Art Unit: Unassigned
)	
Filed: June 3, 2005)	Examiner: Unassigned
)	
For: METHOD OF CUTTING)	
SEMICONDUCTOR SUBSTRATE)	

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Window, Mail Stop Amendment
Alexandria, VA 22314

Sir:

SUPPLEMENTAL PRELIMINARY AMENDMENT

Prior to examination of the above-identified application on the merits, and further to the Preliminary Amendment previously filed on June 3, 2005 in this application, please additionally amend the application as follows: